

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Application of Application No. 10/144,025 of:)
)
)
Riichiro TAKAHASHI et al.)
)
Application No.: Unassigned)
) Prior Application
Filed: April 15, 2004)
) Group Art Unit: 2851
For: ALKALINE SOLUTION AND)
MANUFACTURING METHOD, AND) Examiner: Alan A. MATHEWS
ALKALINE SOLUTION APPLIED TO)
PATTERN FORMING METHOD, RESIST)
FILM REMOVING METHOD, SOLUTION)
APPLICATION METHOD, SUBSTRATE)
TREATMENT METHOD, SOLUTION)
SUPPLY METHOD, AND)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application as follows:

Amendments to the specification begin on page 2 of this paper; and

Amendments to the Claims are reflected in the listing of claims, which begins on page 4 of this paper.

Remarks begin on page 6 of this paper.